Recent Topics in TOF-SIMS Instrumentation at ULVAC-PHI

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The 18th Scientific International Symposium on SIMS Related Techniques Based on Ion-Solid Interactions (SISS)

23th July, 2016

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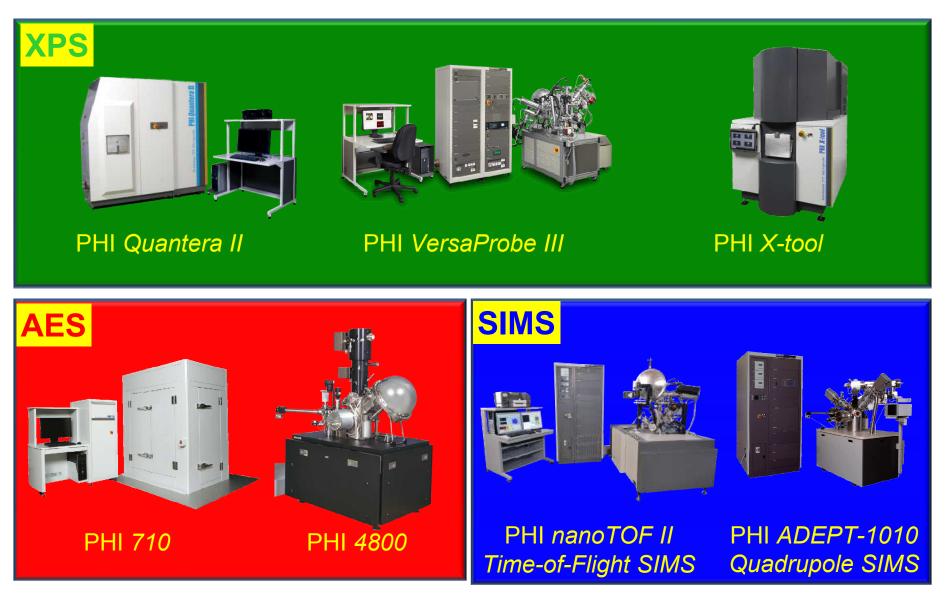
Outline



- **D** Company Introduction
- □ Introduction of PHI nanoTOF II
- **D** Applications
 - 1) FIB-TOF-SIMS
 - 2) MS/MS
- □ Summary

About ULVAC-PHI -The World Leading Manufacturer of Surface Analysis Instruments-





PHI New Products



PHI VersaProbe III



✓ Scanning micro focus X-ray source

✓ High sensitivity

✓Ultimate depth resolution

✓Various types of options



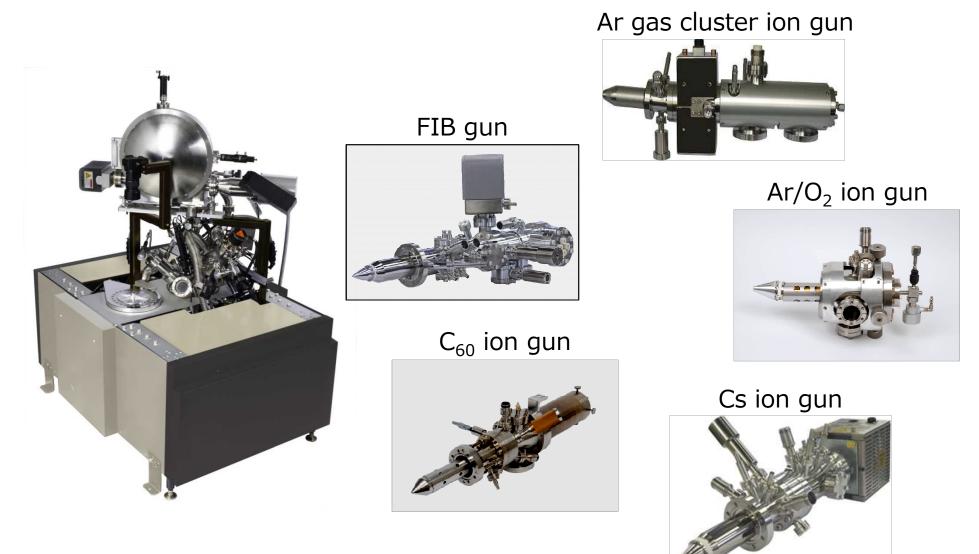
✓SCA analyzer enables us to obtain the AES spectrum with high sensitivity, and high energy resolution

✓ Detailed AES chemical map

Introduction of PHI nanoTOF II



After releasing PHI nanoTOF in 2006, we have provided many components.



Specimen Stage Options



Specimen Stage (standard)



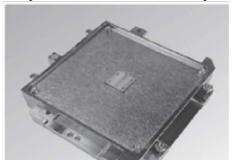
Transfer Vessel



Cold Stage (-150~+150 ℃)



Hot Stage (RT \sim +600 °C)

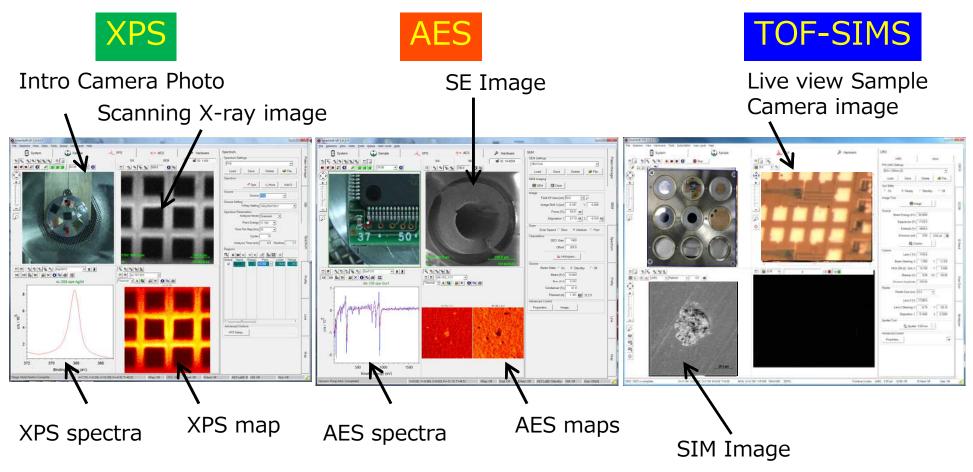


Zalar Rotation



Common Operation Software "SmartSoft"

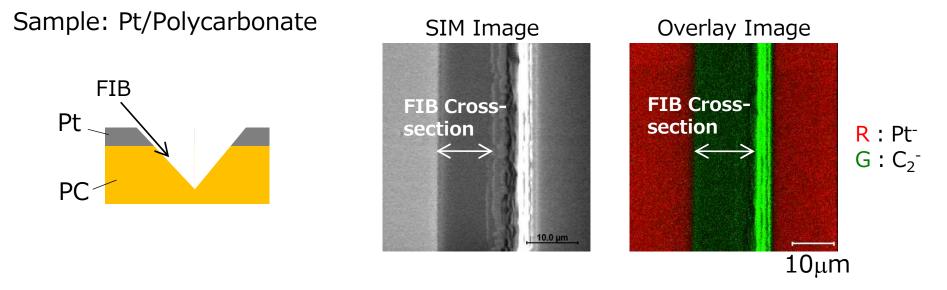




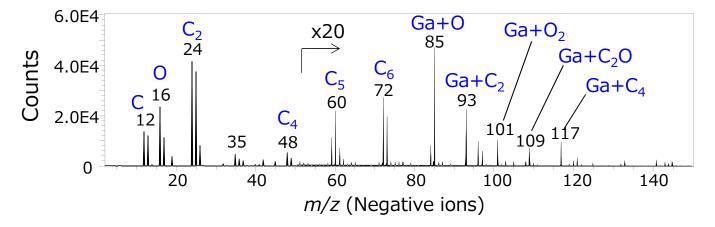
We provide "SmartSoft[™]" for all types of our instruments. The same software interface makes us easy to master the operation of all PHI instruments.

FIB Fabrication of Inorganic/Organic Material





Negative ion spectrum from FIB cross-section



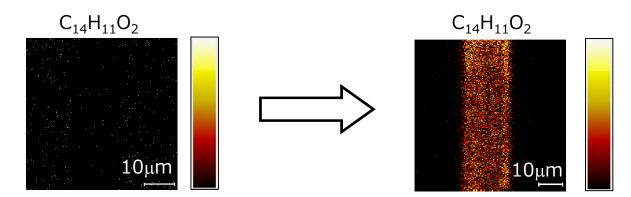
FIB causes damage on the cut surface and leads to no chemical information.

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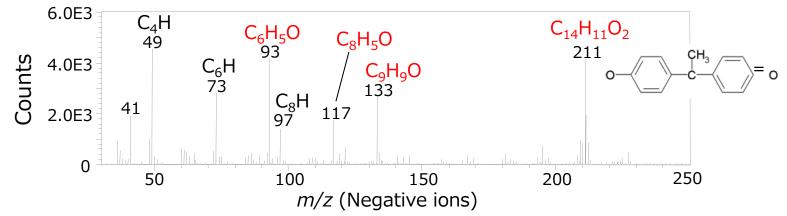
Removal of FIB Induced Damaged Layer

 Φ

After removing the damaged layer by Ar-GCIB...



Negative ion spectrum from FIB cross-section



Combination of FIB and Ar-GCIB enables us to discover the chemical information underneath the metal layer.



Interpretation of a TOF-SIMS spectrum \rightarrow Quite difficult !

(1) Unpredictable fragment pattern

Need to take a spectrum of standard sample in advance.

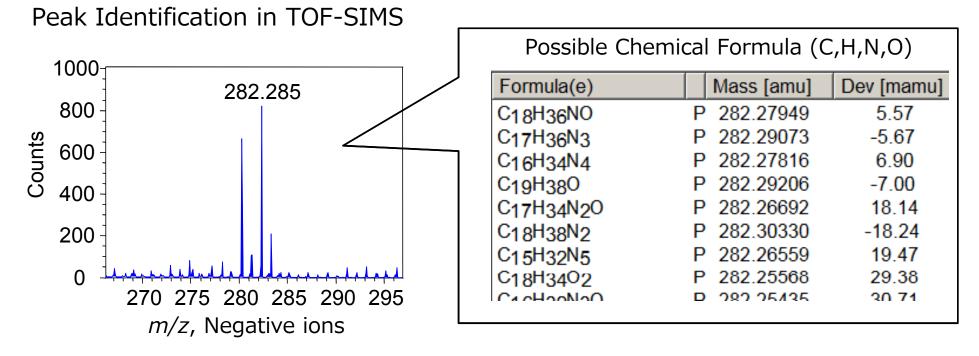
(2) Commercial use of cluster ion beam

Sensitivity of high mass molecular ions are dramatically enhanced. Many peaks are observed at high mass region.

(3) Conventional TOF-SIMS instrument

For molecular ions > 200 Da, difficult to determine the chemical formula from measured mass.

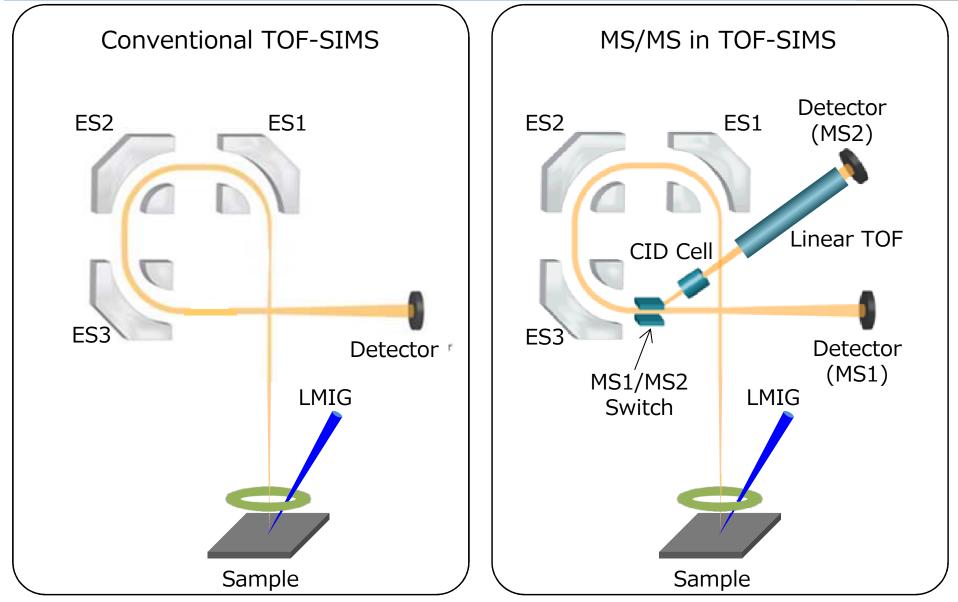




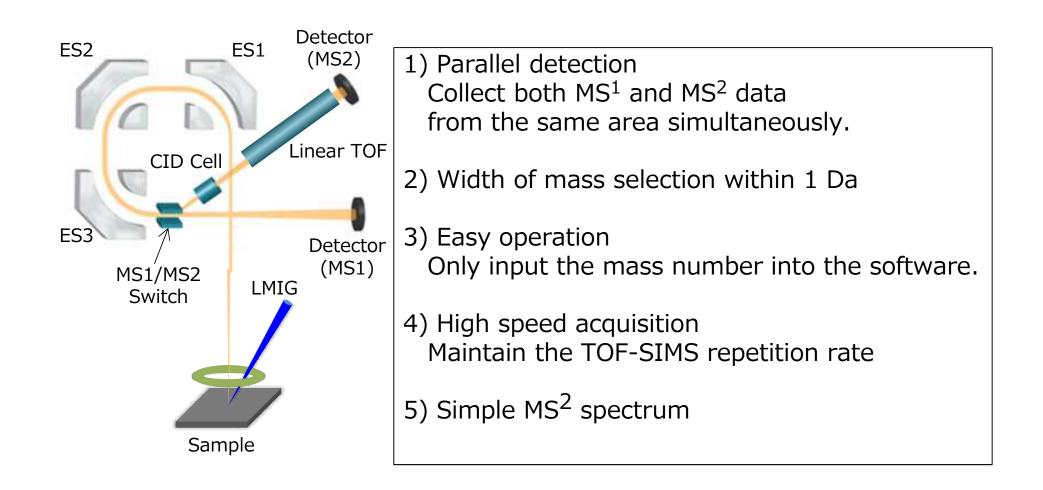
 \rightarrow MS/MS system in TOF-SIMS enables us to overcome the difficulty of the peak identification.

MS/MS in TOF-SIMS





Features of the MS/MS in TOF-SIMS





For further information on the applications of parallel imaging MS/MS, please see the presentation by G.L.Fisher, Physical Electronics

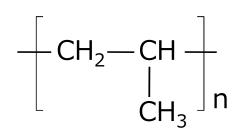
on Friday at 2:50 pm

Sample



Several unknown additives in PP

Polypropylene (PP)



- Analysis Conditions
 - Primary ions:
 - Measurement time:
 - PIDD:

30 keV Bi_{3}^{+} 8 min 7.6 × 10¹¹ ions/cm²

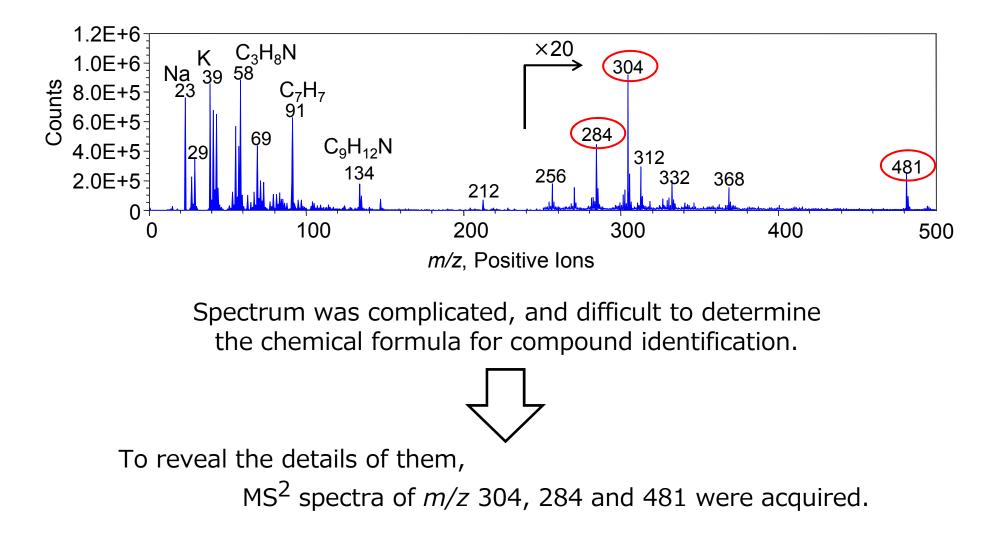




Conventional TOF-SIMS Spectrum

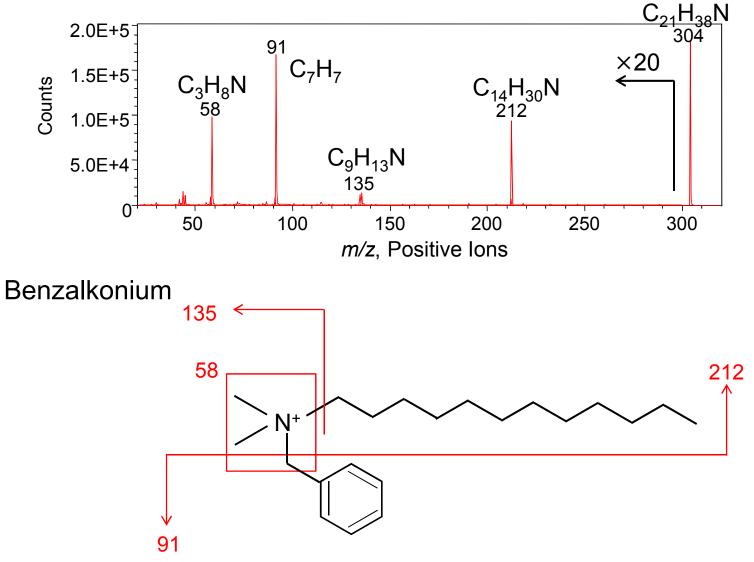


MS¹ (conventional TOF-SIMS) spectrum from PP surface



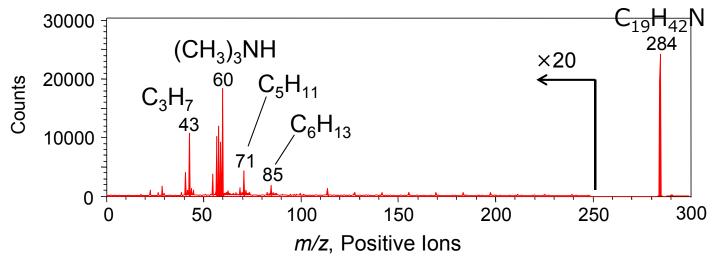


MS^2 Spectrum of m/z 304

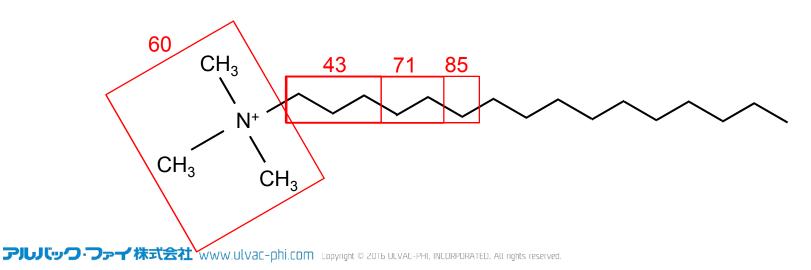




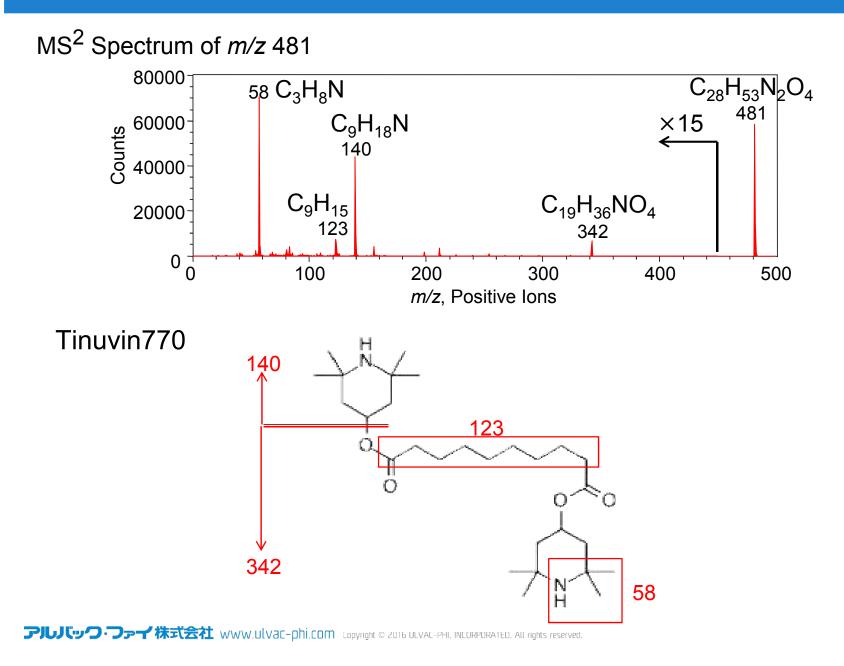
MS^2 Spectrum of m/z 284



Hexadecyltrimethylammonium

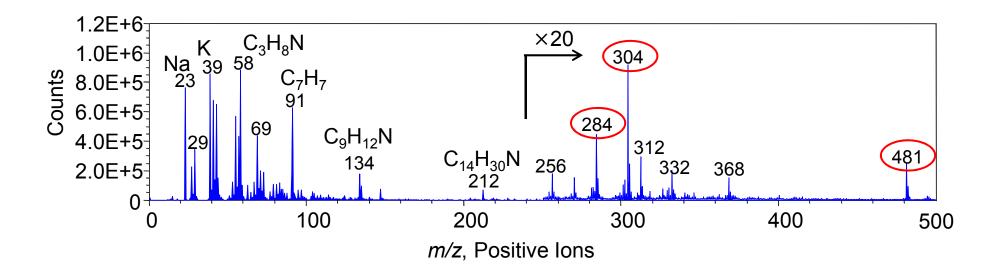








MS¹ spectrum from PP surface



Mass weight (u)	Chemical formula	Compound name
284	C ₁₉ H ₄₂ N	Hexadecyltrimethylammonium
304	C ₂₁ H ₃₈ N	Benzalkonium
481	$C_{28}H_{53}N_2O_4$	Tinuvin770



In this presentation, we introduced our latest options and applications of *nanoTOF* II.

FIB-TOF-SIMS

<Cross-section imaging of organic/inorganic material>

It was possible to remove the damaged layer by Ar-GCIB. Combination of FIB and Ar-GCIB enables us to discover the chemical information underneath the metal layer.

MS/MS

<Identification of unknown additives on polymer surface>

From the MS² spectrum analyses, we can obtain the detailed information on chemical structure, and identify the compound.